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A cost-efficient approach for simultaneous scanning electrochemical microscopy and scanning ion conductance microscopy

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Abstract

A novel and cost-efficient probe fabrication method yielding probes for performing simultaneous scanning electrochemical microscopy (SECM) and scanning ion conductance microscopy (SICM) is presented. Coupling both techniques allows distinguishing topographical and electrochemical activity information obtained by SECM. Probes were prepared by deposition of photoresist onto platinum-coated, pulled fused silica capillaries, which resulted in a pipette probe with an integrated ring ultramicroelectrode. The fabricated probes were characterized by means of cyclic voltammetry and scanning electron microscopy. The applicability of probes was demonstrated by measuring and distinguishing topography and electrochemical activity of a model substrate. In addition, porous boron-doped diamond samples were investigated via simultaneously performed SECM and SICM.

Graphic abstract



Keywords Electrochemistry \cdot Redox reactions \cdot Cyclic voltammetry \cdot Scanning electrochemical microscopy \cdot Scanning ion conductance microscopy \cdot Boron-doped diamond

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Introduction

Scanning electrochemical microscopy (SECM) is a powerful technique for the investigation of electrochemical and topographical properties of surfaces [1]. It belongs to the family of scanning probe techniques and features small electrodes as probes with electroactive diameters of 25 μ m or less, which are termed ultramicroelectrodes (UMEs). Measurements are usually performed in a solution containing a reversible redox-active species, the so-called redox mediator. In the amperometric mode of SECM, a constant potential is applied to the UME, leading to the conversion of the mediator associated with a faradaic current that can be recorded. As the probe is scanned over the surface of a substrate in close proximity, the current changes with respect to the surface properties. However, if the substrate of interest exhibits inhomogeneous topography and electrochemical activity, distinguishing between both types of information becomes challenging. In addition, maintaining a constant probe-to-substrate distance is difficult to guarantee in case of substrates with very inhomogeneous surface topography. To overcome these issues, SECM can be coupled with other techniques such as atomic force microscopy [2, 3]. However, in this approach, contact between the probe and the sample is typically established, which can damage fragile substrates and the probe itself. As a non-contact technique for acquiring topographical information and probe distance control, scanning ion conductance microscopy (SICM) can be utilized [4]. For this technique, a small micropipette is employed as a probe. As it is filled with supporting electrolyte and has a quasi-reference electrode placed within the interior of the pipette, a potential can be applied between the inner electrode and another quasi-reference electrode located in the bulk solution of the measurement cell. This results in an ionic current flowing between the pipette interior and the surrounding solution. Moving the pipette close to the surface leads to hindered ion migration at the pipette orifice, which is manifested by increased resistance and thus, lower current.

Performing SECM and SICM measurements simultaneously enables distinguishable acquisition of topographical and electrochemical activity information on surfaces. For the hyphenation of both techniques, probes with an integrated UME for SECM and a channel with micro- or nanometer size for SICM are required. To date, various approaches for the fabrication of such probes exist. Initial approaches were carried out by Hersam et al. [5] by depositing gold on one side of a nanopipette followed by isolation with Al₂O₃, both applied via atomic layer deposition. Another method features sputtering to create a noble metal surface and isolating the outer surface with electrophoretic paint [6]. Popular means for the fabrication of the UME part of probes feature pyrolysation of butane gas [7–9] or parylene C [10] to create carbon electrodes. The latter has also been used as an insulating material [10, 11]. Alternatively, pulled theta (dual barrel) capillaries were employed as housing of the probe and one barrel was filled with pyrolytic carbon as mentioned above, yielding a carbon barrel for SECM and an empty barrel for SICM. The latter was filled with electrolyte and a Ag/AgCl wire prior to measurements. In all dual-probe fabrication techniques mentioned before, focused ion beam milling is usually utilized to expose the electrode surface. These probes have recently been applied to the investigation of hydrogen peroxide generation at gold nanoparticles [12] and the surface characterization of different cells [9, 13]. Single-barrel nanopipette probes with electrode material deposited around the orifice have been realized with the

methods mentioned above [5, 6, 11] and the characterization of such ring microelectrodes has been reported as well [14-17].

Boron-doped diamond (BDD) is a material exhibiting high chemical stability, inertness, and a wide potential window; therefore, being considered a potent electrode material [18, 19]. Porous BDD provides higher surface area, which results in, e.g., higher sensitivity and selectivity [20, 21]. Non-porous, planar, BDD samples have been investigated via SECM and a non-uniform distribution of electrochemical activity was found [22, 23]. Therefore, in addition to an inhomogeneous surface, variances in the electrochemical activity of porous BDD are expected.

Since existing SECM–SICM dual-probe fabrication methods require sophisticated equipment, we aimed to develop a novel and cost-efficient approach for the preparation of such probes. The fabricated probes were characterized by scanning electron microscopy (SEM) and cyclic voltammetry (CV), revealing information about their size and functionality. The response in SECM and SICM probe approach curves (PACs) towards gold and glass surfaces was tested as well. Eventually, separate images showing the electrochemical activity and morphology of a model substrate and a porous BDD sample were recorded.

Results and discussion

The quality of the coating of the fabricated ring UME pipette probes was investigated by means of CV. Figure 1a shows a CV recorded with a probe being coated six times with a photoresist solution according to the procedure described in the experimental section. Subsequent polishing yielded a probe with a ring diameter of 25 μ m. Figure 1b depicts the corresponding CV. The oxidation currents measured in both cases correspond well to ring UME theory [17] for electrodes with ring diameters of 2 μ m and 25 μ m, respectively. Based on microscopical studies and evaluation of recorded CVs and according to the theory of ring UME voltammetry [17], a thickness of the platinum film of < 50 nm can be estimated for both polished and unpolished probes.

To investigate the response of the probes approaching conducting and non-conducting surfaces, PACs towards gold and polymer on a model substrate were performed. In Fig. 2a, the SECM feedback curves of a 25-µm ring diameter probe approaching both conductor (gold) and isolator (polymer) are displayed. The typical positive and negative feedback responses were found. For SICM, a response-independent conductivity was expected. The corresponding PAC is shown in Fig. 2b. Approaching the surface resulted in initially slowly decreasing current, possibly due to potential shift during the measurement. Nevertheless, when substrateto-tip distance similar to the pipette aperture radius was





Fig. 1 Cyclic voltammograms (CVs) **a** with an unpolished pipette probe with a ring OD of 2 μ m, **b** with a polished pipette probe with a ring OD of 25 μ m. Scan rate: 20 mV s⁻¹. A Pt wire served as quasi-

reference/counter electrode in a solution containing 1.5 mmol dm⁻³ FcMeOH and 0.2 mol dm⁻³ KNO₃



Fig. 2 Probe approach curves (PACs) of a 25 μ m OD dual SECM/SICM probe. **a** SECM PACs, approaching platinum (conductor, red) and insulating polymer (insulator, black). *E* (Probe) = +0.3 V **b** SICM PAC. *E* (Probe) = +0.2 V (color figure online)

reached, the current decreased drastically due to hindered ion migration between pipette interior and bulk solution. Overall, the approach responses indicated proper functionality of the dual probes.

Images of the screen-printed model substrate were recorded to test the capability of the fabricated probes to perform simultaneous local topographical and conductivity studies. Figure 3 shows the SECM (a) and SICM (b) responses at the edge of the conductive electrode area. The SECM image clearly shows a sharp current transition from the conducting gold area in the left half of the image to the insulating polymer in the right half, as positive and negative feedback were measured on the left and right side, respectively. The SICM response indicates a significant roughness over the entire area of the sensor. In addition, overall current increase from the conducting to the insulating area shows that the sensor is thicker at the electrode area, since the electrode material was printed onto the polymer carrier. Both observations could be confirmed by digital micrographs (included in Supporting information Fig. S1).

Furthermore, the fabricated SECM–SICM probes were utilized to investigate a porous BDD sample regarding its electrochemical surface properties in relation to topography. In Fig. 4a, the SECM image showing overlapping electrochemical and topographical information is presented. Locations exhibiting higher currents indicated either the occurrence of higher electrochemical activity or topographical extrusion of the surface. To differentiate between these two types of information, the SICM image displayed in Fig. 4b can be utilized, covering the same area previously investigated via SECM. Herein, low current areas as a result of a small substrate-to-tip distance indicate the presence of

Current/nA

14.1

12.4



Fig. 3 a Electrochemical activity (SECM) and b topographical (SICM) images of an electrochemical sensor substrate obtained via simultaneous SECM and SICM recordings. 2D (top) and 3D (bottom) projections are shown. An area of 45 × 300 µm was investigated, cov-

topographical elevation. Digital micrographs of the sample, shown in Fig. 4c, support these observations. Extrusions generally occur in the same locations where the high current was observed in the SECM image. Nevertheless, deviations were noticeable, as areas exhibiting both low electrochemical activity and topological extrusions occurred as well. Therefore, variations in the SECM might be caused by both inhomogeneous topography and porosity of the sample, in addition to electrochemical differences. The latter is possibly a consequence of non-uniform distribution of boron doping ratio within the BDD layer. Similar observations were made for nonporous BDD samples [24].

Conclusion

A new approach for the fabrication of probes suitable for simultaneous SECM and SICM measurements was developed and functional probes of different size were successfully manufactured. In addition, the materials and instruments required for the preparation of probes are cost efficient and easy to acquire. The probes were characterized via CV, SEM images, and PACs towards isolating and conducting surfaces. Electrochemical and topographical variations at a model substrate surface as well as a porous BDD sample could be resolved. The probe preparation concept suggested in this work facilitates the widespread use of combined SECM and SICM as a means for simultaneous non-contact



250

275

0.00

50 75 100 125 150 175 200 225

Distanceum

topographical and electrochemical activity studies of surfaces.

Experimental

(b)

14.0

13.5 13.0

Current/nA 12.5 12.0 11.

11.

25

100 125 150 175 200 225 250 275

Distance/um

75

All experiments were carried out with ferrocenemethanol ($c = 1.5 \text{ mmol } \text{dm}^{-3}$, FcMeOH, 99%, ABCR, Karlsruhe, Germany) or hexaamineruthenium(III) chloride ($c = 1.5 \text{ mmol dm}^{-3}$, Ru(NH₃)₆Cl₃, ABCR, Karlsruhe, Germany) as a redox mediator. To prepare aqueous solutions, Milli-Q water (Milli-Q Advantage A10 system, Merck Millipore, Darmstadt, Germany) was used. KNO3 $(c=0.2 \text{ mol } dm^{-3}, \text{ analytical grade, Merck KGaA, Darm-}$ stadt, Germany) and KCl ($c = 0.2 \text{ mol dm}^{-3}$, analytical grade, Merck KGaA, Darmstadt, Germany) served as supporting electrolytes. A 10:1 mixture of SU8.5 photoresist (MicroChem Corp., Westborough, Massachusetts) and ethanol (Merck Millipore, Burlington, Massachusetts) was utilized for preparing isolating coatings.

Instrumentation

Probes were fabricated by modifying platinum-coated emitters for electrospray ionization (New Objective, Woburn, Massachusetts). The fabrication protocol is illustrated in Fig. 5. Initially, the capillaries were pushed



Fig. 4 a SECM and b SICM images of a porous BDD sample, recorded simultaneously. An area of 294×294 µm was scanned. Increment distance: 3 µm; mediator for SECM: Ru(NH₃)₆Cl₃; E (Probe, SECM) = -0.4 V. E (Substrate, SECM) = 0 V. E (Probe,

polished

SICM) = +0.2 V. Scan rate: 30 µm s⁻¹. Quiet time: 60 s. c Optical micrograph of a porous BDD sample showing the topographical characteristics



through a copper tube (1.1 mm ID, 2.0 mm OD, 3.0 cm length, Albion Alloys, Bournemouth, United Kingdom) for establishing electrical contact to the platinum surface of the probes. Contact between copper and platinum was established using silver conductive paint (VS Electronic, Aschaffenburg, Germany) and adhesive (UHU Max Repair Extreme, UHU GmbH & Co. KG, Bühl, Germany). Afterwards, a photoresist solution was applied under N₂ flow, cured by UV light (350 nm, applied for 30 s) and heated in an oven at 95 °C for 5 min to evaporate the remaining solvent. The quality of the coating was investigated by CV and the coating process was repeated if the measured currents were too high. If larger probes were desired, an alternative way to expose a ring electrode surrounding was applied. The tips were polished with alumina lapping sheets (0.3 µm, Precision Surfaces International, Houston, Texas), while water was flushed through the pipette to prevent clogging.

Eventually, probes were filled with supporting electrolyte and a Ag/AgCl wire was inserted. Figure 6a shows a typical example of a finished tip. The individual layers of the probe tip are schematically shown in Fig. 6b. An image of the



tip recorded with a SEM (JSM-6400F, Jeol Ltd., Akishima, Japan) is depicted in Fig. 6c.

Experiments with the fabricated probes were performed with a second Ag/AgCl wire placed in the bulk solution employed as both counter and reference electrode for SECM measurements. The mentioned potentials herein refer to this reference system if not stated otherwise.

Measurements were performed using a commercially available SECM 920C (CH Instruments, Austin, Texas), with the first electrode channel being connected to the internal Ag/AgCl wire of the ring UME pipette for recording the SICM current and the second channel connected to the copper tube for measuring the SECM current.

The approach response of the fabricated probes was investigated by performing PACs over both gold and polymer of a screen-printed electrochemical sensor (Fig. 7a, b, GlucoSmart® Swing, MSP bodmann GmbH, Germany) as conductive and non-conductive surfaces, respectively. A potential of +0.3 V (SECM) was applied and the probe was approached until the SECM current increased to 135% (conductor) or decreased to 85% (insulator) with respect to the current measured in bulk solution. In addition, a quiet time of 60 s was applied prior to approaching and the scan rate was set to $1.25 \ \mu m \ s^{-1}$.

For simultaneous SECM and SICM measurements, the contact pads of the same sensor served as a model substrate. Its roughness and the transition between conducting and insulating surface were investigated. Potentials of +0.3(SECM) and +0.2 V (SICM) were applied and FcMeOH served as a redox mediator. The scan rate of the probe was 40 µm s^{-1} with a pixel size of 4 µm.

Porous BDD samples were deposited on conductive p-Si wafers with a planar BDD base layer using an ASTeX 5010 (Seki Technotron, Japan) deposition system under the following conditions: 0.5% of methane in hydrogen, gas pressure equal to 50 mbar, microwave power of 1150 W, and substrate temperature of ca. 750 °C. Boron doping was carried out by the addition of trimethylboron in the gas phase to give a B/C ratio of 4000 ppm. Porous BDD samples were obtained by two-step diamond deposition (a growth duration of each step was 5 h) on a ca. 4–5 µm thick 3D template comprising of nanodiamond seeded SiO₂ nanofibers in a polymer solution, which was spin coated (at 3000 rpm for 30 s) on top of a planar BDD base layer and then dried on



Fig. 7 a Image of the electrochemical sensor used as a model substrate. b Zoomed view of the electrode pads of the glucose sensor with the area investigated by means of SECM/SICM highlighted in a hot plate (110 °C/90 s). The surface of fabricated porous BDD samples was hydrogen terminated (as-grown).

The BDD samples were mounted onto a substrate holder prior to measurements (Fig. 7c), enabling a well-defined potential setting of the BDD sample. The sample holder consisted of a brass rod sealed with polyvinyl chloride (brass diameter: 3 mm, outer diameter of the polyvinyl chloride hollow cylinder: 6.5 mm, fabricated by the mechanical workshop of the University of Regensburg), with the rod exceeding on one end to facilitate electrical contact and another flat end where porous BDD samples were mounted. Electrical contact between porous BDD and brass rod was established by applying silver conductive paint on the rod and placing the porous BDD sample on top. After drying at room temperature for 1 h, the gap between rod and sample was sealed with epoxide resin (UHU plus endfest 300, UHU GmbH & Co. KG, Bühl, Germany). After hardening of the resin, which required 24 h, the remaining gaps were filled with epoxy resin as before. Excess resin was removed by carefully polishing the edges of the sample with abrasive paper (grit size 100) until the sample fit into the electrochemical cell shown in Fig. 7d. Porous BDD samples were measured with $Ru(NH_3)_6Cl_3$ as a mediator, applying 0.0 V to the substrate and -0.4 and +0.2 V to the SECM and SICM parts of the probe, respectively. An area of 294×294 µm was investigated at a scan rate of 30 μ m s⁻¹ and a pixel size of 3 μ m. Initial surface studies of the samples were performed with a digital microscope (VHX-7000, Keyence, Osaka, Japan).

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